

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 7718

Tetsuji TOGAWA et al.

Docket No. 2001 1521A

Serial No. 09/973,842

Group Art Unit 3723

Filed October 11, 2001

Examiner R.A. ROSE

PRECEIVED

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SUBSTRATE HOLDING APPARATUS

## RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

This is in response to the Restriction Requirement of September 4, 2003.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a polishing apparatus and corresponds to claims 1-60, and also elect Species A, which corresponds to Figs. 1-6 and on which claims 1-27 and 57-60 are readable.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Tetsuji TOGAWA et al.

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